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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/712,818	11/12/2003	Mark R. Fernald	CC-0675	8840

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EXAMINER	
WASHBURN, DOUGLAS N	
ART UNIT	**PAPER NUMBER**
2863	

DATE MAILED: 06/01/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary	Application No.	Applicant(s)	
	10/712,818	FERNALD ET AL.	
	Examiner	Art Unit	
	Douglas N. Washburn	2863	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

1)☒ Responsive to communication(s) filed on *09 May 2006*.

2a)☐ This action is **FINAL**. 2b)☒ This action is non-final.

3)☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

4)☒ Claim(s) *1-8 and 10-39* is/are pending in the application.

4a) Of the above claim(s) _____ is/are withdrawn from consideration.

5)☐ Claim(s) _____ is/are allowed.

6)☒ Claim(s) *1-8,10, 11,14-17,23-34 and 37* is/are rejected.

7)☒ Claim(s) *12,13,18-22,35,36,38 and 39* is/are objected to.

8)☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

9)☐ The specification is objected to by the Examiner.

10)☒ The drawing(s) filed on *12 September 2005* is/are: a)☒ accepted or b)☐ objected to by the Examiner.

Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).

Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).

11)☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

12)☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).

a)☐ All b)☐ Some * c)☐ None of:

1.☐ Certified copies of the priority documents have been received.

2.☐ Certified copies of the priority documents have been received in Application No. _____.

3.☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

1) ☒ Notice of References Cited (PTO-892)
2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
3) ☒ Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date *9 May 2006*.
4) ☐ Interview Summary (PTO-413) Paper No(s)/Mail Date. _____ .
5) ☐ Notice of Informal Patent Application (PTO-152)
6) ☐ Other: _____.

DETAILED ACTION

Information Disclosure Statement

1 The information disclosure statement filed 9 May 2006 fails to comply with 37 CFR 1.98(a)(3) because it does not include a concise explanation of the relevance, as it is presently understood by the individual designated in 37 CFR 1.56(c) most knowledgeable about the content of the information, of each patent listed that is not in the English language. It has been placed in the application file, but the information referred to therein has not been considered.

Response to Amendment

2 Applicant amendment overcomes objection to claims 26, 29 and 34 and the objection is withdrawn.

The indicated allowability of claims 2, 5-7, 29-31 and 34 is withdrawn in view of the newly discovered references to a single phase fluid and a multi-phase mixture; strain sensors include an attachment device for securing the ends of the strap of the strain sensor to clamp the strain sensor onto a pipe; the ends of at least one of the strain sensors are removably attached together to enable the removable and reattachment to a pipe; and the ends of at least one of the strain sensors are permanently attached together. Rejections based on the newly cited references follow.

Claim Rejections - 35 USC § 102

3 The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

> A person shall be entitled to a patent unless –
> (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-7, 11, 15-17, 23-31 and 34 are rejected under 35 U.S.C. 102(b) as being anticipated by Gysling et al. (US 6,354,147) (Hereafter referred to as Gysling).

Gysling teaches:

At least two strain (pressure) sensors (column 5, lines 50-52) clamped (column 19, lines 17-21) onto the outer surface of a pipe (column 15, lines 60-65) at different axial locations along the pipe (column 5, lines 50-52; figure 1, elements X_1, X_2 and X_3), each of the pressure sensors providing a respective pressure signal indicative of a pressure disturbance within the pipe at a corresponding axial position (column 5, lines54-57) in regard to claim 1;

A strap (strapping) (column 19, lines 17-21) in regard to claims 1 and 26;

A piezoelectric film material (piezoelectric strain gauge) having a pair of conductors disposed on opposing surfaces thereof whereby the piezoelectric film is attached to the strap (column 19, lines 30-33) in regard to claims 1 and 26;

A signal processor (signal processor), responsive to said pressure signals, which provides a signal indicative of at least one parameter of a process flow flowing within a pipe (column 2, lines 9-11) in regard to claim 1;

The process flow is one of a single phase fluid and a multi-phase mixture (column 21, lines 6-10) in regard to claim 2;

A piezoelectric film sensor is attached to the outer surface of a strap (column 15, lines 60-65) in regard to claim in regard to claims 3 and 27;

A strap is a metallic material (column 19, lines 17-21) in regard to claims 4 and 28;

At least one of the strain sensors include an attachment device for securing the ends of the strap of the strain sensor to clamp the strain sensor onto a pipe (column 19, lines 17-21) in regard to claims 5 and 29;

The ends of at least one of the strain sensors are removably attached together to enable the removable and reattachment to a pipe (column 19, lines 17-21) in regard to claims 6 and 30;

The ends of at least one of the strain sensors are permanently attached together (column 19, lines 17-21) in regard to claims 7 and 31;

A piezoelectric film extends around a substantial portion of the circumference of a pipe (column 15, lines 37-41) in regard to claims 11 and 34;

Pressure signals are indication of acoustic pressures propagating within a pipe (column 5, lines 50-52) in regard to claim 15 and 23;

A parameter of a fluid is one of steam quality or "wetness", vapor/mass ratio, liquid/solid ratio, volumetric flow rate, mass flow rate, size of suspended particles, density, gas volume fraction, and enthalpy of a flow (column 2, lines 66 et seq; column 3, lines 1-9) in regard to claim 16;

A signal processor determines the slope of an acoustic ridge in the k-w plane to determine a parameter of the process flow flowing in the pipe (column 23, lines 5-23) in regard to claim 17;

Each sensor measures an acoustic pressure and provides a signal indicative of an acoustic noise within a pipe (column 15, lines 37-41) in regard to claim 23;

At least three pressure sensors (column 5, lines 50-52; figure 1, elements 14, 16 and 18) in regard to claim 24;

And strain sensors include pressure sensors (column 15, lines 60-65) in regard to claim 25.

Claim Rejections - 35 USC § 103

4 The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

> (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 8, 14, 32 and 37 are rejected under 35 U.S.C. 103(a) as being unpatentable over Gysling et al. (US 6,354,147) (Hereafter referred to as Gysling) in view of Krempl et al. (US 4,216,403) (Hereafter referred to as Krempl).

Gysling teaches:

At least two strain (pressure) sensors (column 5, lines 50-52) clamped (column 19, lines 17-21) onto the outer surface of a pipe (column 15, lines 60-65) at different axial locations along the pipe (column 5, lines 50-52; figure 1, elements X_1, X_2 and X_3), each of the pressure sensors providing a respective pressure signal indicative of a pressure disturbance within the pipe at a corresponding axial position (column 5, lines54-57) in regard to claim 1;

A strap (strapping) (column 19, lines 17-21) in regard to claims 1 and 26;

A piezoelectric film material (piezoelectric strain gauge) having a pair of conductors disposed on opposing surfaces thereof whereby the piezoelectric film is attached to the strap (column 19, lines 30-33) in regard to claims 1 and 26;

A signal processor (signal processor), responsive to said pressure signals, which provides a signal indicative of at least one parameter of a process flow flowing within a pipe (column 2, lines 9-11) in regard to claim 1;

The process flow is one of a single phase fluid and a multi-phase mixture (column 21, lines 6-10) in regard to claim 2;

A piezoelectric film sensor is attached to the outer surface of a strap (column 15, lines 60-65) in regard to claim in regard to claims 3 and 27;

A strap is a metallic material (column 19, lines 17-21) in regard to claims 4 and 28;

At least one of the strain sensors include an attachment device for securing the ends of the strap of the strain sensor to clamp the strain sensor onto a pipe (column 19, lines 17-21) in regard to claims 5 and 29;

The ends of at least one of the strain sensors are removably attached together to enable the removable and reattachment to a pipe (column 19, lines 17-21) in regard to claims 6 and 30;

The ends of at least one of the strain sensors are permanently attached together (column 19, lines 17-21) in regard to claims 7 and 31;

A piezoelectric film extends around a substantial portion of the circumference of a pipe (column 15, lines 37-41) in regard to claims 11 and 34;

Pressure signals are indication of acoustic pressures propagating within a pipe (column 5, lines 50-52) in regard to claim 15 and 23;

A parameter of a fluid is one of steam quality or "wetness", vapor/mass ratio, liquid/solid ratio, volumetric flow rate, mass flow rate, size of suspended particles, density, gas volume fraction, and enthalpy of a flow (column 2, lines 66 et seq; column 3, lines 1-9) in regard to claim 16;

A signal processor determines the slope of an acoustic ridge in the k-w plane to determine a parameter of the process flow flowing in the pipe (column 23, lines 5-23) in regard to claim 17;

Each sensor measures an acoustic pressure and provides a signal indicative of an acoustic noise within a pipe (column 15, lines 37-41) in regard to claim 23;

At least three pressure sensors (column 5, lines 50-52; figure 1, elements 14, 16 and 18) in regard to claim 24;

And strain sensors include pressure sensors (column 15, lines 60-65) in regard to claim 25.

Gysling is silent regarding:

The piezoelectric film material includes at least one of polyvinylchlorine fluoride (PDVF), polymer film and flexible PZT in regard to claims 8 and 32;

Each of the pair of conductors is a coating of silver ink in regard to claims 10 and 33;

Piezoelectric film has a thickness greater than 8 mm in regard to claims 12 and 35;

Piezoelectric film has a thickness between 8 mm and 120 mm in regard to claims 13 and 36;

An electrical insulator between the piezoelectric film material and the strap in regard to claims 14 and 37;

Strain signals are indication of vortical disturbances within the fluid flow in regard to claim 18;

The parameter of the fluid is one of velocity of the process flow and the volumetric flow of the process fluid in regard to claim 19;

The signal processor determines the slope of a convective ridge in the k-ω plane to determine the velocity of the fluid flowing in the pipe in regard to claim 20;

The signal processor determines the volumetric flow rate of the fluid flowing in the pipe in response to the velocity of the fluid in regard to claim 21;

The signal processor generates a flow velocity signal indicative of the velocity of the fluid flowing within the pipe by cross-correlating the strain signals in regard to claim 22;

The piezoelectric film material is attached to the inner surface of the strap in regard to claim 38;

And the piezoelectric film material is attached to the inner surface of the strap in regard to claim 39.

Krempl teaches:

The piezoelectric film material includes at least one of polyvinylchlorine fluoride (PDVF), polymer film and flexible PZT (column 8, lines 29 and 30) in regard to claims 8 and 32;

And an electrical insulator between the piezoelectric film and the strap (column 7, lines 44-47; figure 5, elements 19 and 20) in regard to claims 14 and 37;

Regarding claims 8 and 32, it would have been obvious to one skilled in the art at the time of the instant invention to modify the teaching of Gysling of a piezoelectric film material having a pair of conductors disposed on opposing surfaces and the piezoelectric film is attached to a strap with the teaching of Krempl of The piezoelectric film material includes at least one of polyvinylchlorine fluoride (PDVF), polymer film and flexible PZT because such piezoelectrics show a longitudinal piezoelectric effect in the direction of the Z axis (axes according to the IRE-convention) and transversal piezoelectric effects in the directions of the X or Y axis respectively.

Regarding claims 14 and 37, it would have been obvious to one skilled in the art at the time of the instant invention to modify the teaching of Gysling of a piezoelectric film material having a pair of conductors disposed on opposing surfaces and the piezoelectric film is attached to a strap with the teaching of Krempl of an electrical insulator between the piezoelectric film and the strap because the insulating tapes would have provided electrical isolation between the electrodes of sensor element and leader ends.

Claims 10 and 33 are rejected under 35 U.S.C. 103(a) as being unpatentable over Gysling in view of French (US 4,833,271)(Hereafter referred to as French).

Gysling teaches:

At least two strain (pressure) sensors (column 5, lines 50-52) clamped (column 19, lines 17-21) onto the outer surface of a pipe (column 15, lines 60-65) at different axial locations along the pipe (column 5, lines 50-52; figure 1, elements X_1, X_2 and X_3), each of the pressure sensors providing a respective pressure signal indicative of a pressure disturbance within the pipe at a corresponding axial position (column 5, lines54-57) in regard to claim 1;

A strap (strapping) (column 19, lines 17-21) in regard to claims 1 and 26;

A piezoelectric film material (piezoelectric strain gauge) having a pair of conductors disposed on opposing surfaces thereof whereby the piezoelectric film is attached to the strap (column 19, lines 30-33) in regard to claims 1 and 26;

A signal processor (signal processor), responsive to said pressure signals, which provides a signal indicative of at least one parameter of a process flow flowing within a pipe (column 2, lines 9-11) in regard to claim 1;

The process flow is one of a single phase fluid and a multi-phase mixture (column 21, lines 6-10) in regard to claim 2;

A piezoelectric film sensor is attached to the outer surface of a strap (column 15, lines 60-65) in regard to claim in regard to claims 3 and 27;

A strap is a metallic material (column 19, lines 17-21) in regard to claims 4 and 28;

At least one of the strain sensors include an attachment device for securing the ends of the strap of the strain sensor to clamp the strain sensor onto a pipe (column 19, lines 17-21) in regard to claims 5 and 29;

The ends of at least one of the strain sensors are removably attached together to enable the removable and reattachment to a pipe (column 19, lines 17-21) in regard to claims 6 and 30;

The ends of at least one of the strain sensors are permanently attached together (column 19, lines 17-21) in regard to claims 7 and 31;

A piezoelectric film extends around a substantial portion of the circumference of a pipe (column 15, lines 37-41) in regard to claims 11 and 34;

Pressure signals are indication of acoustic pressures propagating within a pipe (column 5, lines 50-52) in regard to claim 15 and 23;

A parameter of a fluid is one of steam quality or "wetness", vapor/mass ratio, liquid/solid ratio, volumetric flow rate, mass flow rate, size of suspended particles, density, gas volume fraction, and enthalpy of a flow (column 2, lines 66 et seq; column 3, lines 1-9) in regard to claim 16;

A signal processor determines the slope of an acoustic ridge in the k-w plane to determine a parameter of the process flow flowing in the pipe (column 23, lines 5-23) in regard to claim 17;

Each sensor measures an acoustic pressure and provides a signal indicative of an acoustic noise within a pipe (column 15, lines 37-41) in regard to claim 23;

At least three pressure sensors (column 5, lines 50-52; figure 1, elements 14, 16 and 18) in regard to claim 24;

And strain sensors include pressure sensors (column 15, lines 60-65) in regard to claim 25.

Gysling is silent regarding:

The piezoelectric film material includes at least one of polyvinylchlorine fluoride (PDVF), polymer film and flexible PZT in regard to claims 8 and 32;

Each of the pair of conductors is a coating of silver ink in regard to claims 10 and 33;

Piezoelectric film has a thickness greater than 8 mm in regard to claims 12 and 35;

Piezoelectric film has a thickness between 8 mm and 120 mm in regard to claims 13 and 36;

An electrical insulator between the piezoelectric film material and the strap in regard to claims 14 and 37;

Strain signals are indication of vortical disturbances within the fluid flow in regard to claim 18;

The parameter of the fluid is one of velocity of the process flow and the volumetric flow of the process fluid in regard to claim 19;

The signal processor determines the slope of a convective ridge in the k-ω plane to determine the velocity of the fluid flowing in the pipe in regard to claim 20;

The signal processor determines the volumetric flow rate of the fluid flowing in the pipe in response to the velocity of the fluid in regard to claim 21;

The signal processor generates a flow velocity signal indicative of the velocity of the fluid flowing within the pipe by cross-correlating the strain signals in regard to claim 22;

The piezoelectric film material is attached to the inner surface of the strap in regard to claim 38;

And the piezoelectric film material is attached to the inner surface of the strap in regard to claim 39.

French teaches:

Each of the pair of conductors is a coating of silver ink (column 7, lines 4-7) in regard to claims 10 and 33;

Regarding Claims 10 and 33, it would have been obvious to one skilled in the art at the time of the instant invention to modify the teaching of Gysling of a piezoelectric film material (piezoelectric strain gauge) having a pair of conductors disposed on opposing surfaces with the teaching of French of a polyvinylidene fluoride (PVDF) film, sandwiched between thin metallized layers of electrically conductive metal and the opposed metallized layers are silver because a polyvinylidene fluoride (PVDF) film, sandwiched between thin metallized layers of electrically conductive metal and the opposed metallized layers are silver would have been a highly sensitive sensor for measuring unsteady pressures within a pipe.

Response to Arguments

5 Applicant's arguments, see amendment, filed 9 May 2006, with respect to the rejection of claims 26-28, 32 and 33 under §102(b) have been fully considered and are persuasive. Therefore, the rejection has been withdrawn. However, upon further consideration, a new grounds of rejection is made.

Applicant's arguments, see amendment, filed 9 May 2006, with respect to the rejection of claims 1, 3, 4, 8, 10, 11, 15-17, 23-28, 32 and 33 under §103(a) have been fully considered and are persuasive. Therefore, the rejection has been withdrawn. However, upon further consideration, a new grounds of rejection is made.

Allowable Subject Matter

6 Claims 12, 13, 18-22, 35, 36, 38 and 39 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

The following is an examiner's statement of reasons for allowance:

Claim 12 recites, in part, "piezoelectric film has a thickness greater than 8 mm". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 13 recites, in part, "piezoelectric film has a thickness between 8 mm and 120 mm". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 18 recites, in part, "strain signals are indication of vortical disturbances within the fluid flow". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 19 recites, in part, "the parameter of the fluid is one of velocity of the process flow and the volumetric flow of the process fluid". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 20 recites, in part, "the signal processor determines the slope of a convective ridge in the k-ω plane to determine the velocity of the fluid flowing in the pipe". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 21 recites, in part, "the signal processor determines the volumetric flow rate of the fluid flowing in the pipe in response to the velocity of the fluid". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 22 recites, in part, "the signal processor generates a flow velocity signal indicative of the velocity of the tluid flowing within the pipe by cross-correlating the strain signals". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 35 recites, in part, "piezoelectric film has a thickness greater than 8 mm". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 36 recites, in part, "piezoelectric film has a thickness between 8 mm and 120 mm". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 38 recites, in part, "the piezoelectric film material is attached to the inner surface of the strap". This feature in combination with the remaining claimed structure avoids the prior art of record.

Claim 39 recites, in part, "the piezoelectric film material is attached to the inner surface of the strap". This feature in combination with the remaining claimed structure avoids the prior art of record.

It is these limitations, which are not found, taught or suggested in the prior art of record, and are recited in the claimed combination that makes these claims allowable over the prior art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

7 Any inquiry concerning this communication or earlier communications from the examiner should be directed to Douglas N. Washburn whose telephone number is (571) 272-2284. The examiner can normally be reached on Monday through Thursday 6:30 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John E. Barlow can be reached on (571) 272-2269. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

MICHAEL NGHIEM
PRIMARY EXAMINER

DNW